

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shinji MAEKAWA et al.)
Serial No.: 10/827,457)
Filed: April 19, 2004)
For: Method For Forming Pattern And)
Drop Discharge Apparatus)
Examiner: Marianne L. Padgett)
Art Unit: 1715)
Confirmation No.: 2984)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT J (AFTER FINAL)

Applicants have the following response to the Final Rejection of June 23, 2009.

Please amend the above-identified application as follows: